PATENT

Atty Docket No.: 10004808-1

In The U.S. Patent and Trademark Office

RECEIVED CENTRAL FAX CENTER

In Re the Application of:

Inventor(s): Osamu S. Nakagawa et al.

Confirmation No.: 3635

AUG 2 4 2006

Serial No.:

09/891,324

Examiner: Schillinger, Laura M.

Filed:

June 27, 2001

Group Art Unit:

2813

Title:

PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR

METAL CAPACITOR IN VLSI MULTI-LEVEL METALIZATION

SYSTEMS

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TO THE USPTO

I hereby certify that this correspondence is being transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on August 24, 2006. This correspondence contains the following document(s):

1 sheet of Transmittal Letter for Response/Amendment (2 copies).

13sheets of Amendment Under 37 C.F.R. § 1.111.

Respectfully submitted,

MANNAVA & KANG, P.C.

August 24, 2006

Timothy B. Kang

Registration No.: 46,423

MANNAVA & KANG, P.C. 8221 Old Courthouse Road

Suite 104

Vienna, VA 22182

(703) 652-3817

(703) 865-5150 (facsimile)

PATENT APPLICATION

Intellectual Property Administration P. O. Box 272400 Fort Collins, Colorado 80527-2400

ATTORNEY DOCKET NO. 10004808-1

IN THE

UNITED STATES PATENT AND TRADEMARK OFFICE

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PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR METAL CAPACITOR

IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

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Mail Stop Amendment Commissioner For Patents PO Box 1450 Alexandria, VA 22313-1450

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Sir:													
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()	New fee	as calculated below		() Supplemental Declaration									
(X)	No additi	onal fee											
()	Other:								(fee \$				
Г	CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY												
ľ	(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) (4) NUMBER HIGHEST NI EXTRA PREVIOUSLY			(5) PRESENT R EXTRA		(8) RATE		(7) ADDITIONAL PEES			
_	TOTAL CLAIMS	20	MINUS	20		=	= o		\$50	\$	0		
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	EXTENSION 1ST MONTH FEE 0120.00 [2ND MONTH 3RD MON 9450.00 91020.0						\$	0			

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted.

TOTAL ADDITIONAL FEE FOR THIS AMENDMENT

(X) I hereby certify that this paper is being transmitted to the Patent and Trademark Office (acsimlio number 1571) 273-8300 on Aug 28, 2006 Number of pages: 19
Typed Name: Timothy B. Keng
Signature:

Osamu S. Nakagawa

Timothy B. Kang

Attorney/Agent for Applicant(s)

OTHER FEES

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\$

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Reg. No. 46,423

P. O. Box 272400 Fort Collins, Colorado 80527-2400 ATTORNEY DOCKET NO.

10004808-1

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Inventor(s):

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Titlo:

Sir:

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IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

Transmitted herewith is/are the following in the above-identified application:

Mail Stop Amendment Commissioner For Patents PO Box 1450 Alexandria, VA 22313-1450

RECEIVED CENTRAL FAX CENTER

AUG 2 4 2006

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

UNITED STATES PATENT AND TRADEMARK OFFICE

;} } ;}	Response/Amendment New fee as calculated below No additional fee				() Petition to extend time to respond () Supplemental Declaration							
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	CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY											
	(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT		(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR		(S) PRESENT EXTRA		(6) RATE		(7) ADDITIONAL FEES	
	TOTAL CLAIMS	20		MINUS	20		-	0	×	\$50	\$	0
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Γ	OTHER FEES									\$		
	TOTAL ADDITIONAL FEE FOR THIS AMENDMENT									\$	0	

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_Бу __

Typed Name: Timothy B. Kang

Timothy B. Kang

Signature;

Attorney/Agent for Applicant(s) Reg. No. 46,423

(FAX)703 865 5150

P. 004/016

HEWLETT-PACKARD COMPANY

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AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Official Action dated May 24, 2006, kindly amend the application identified above as follows. In the following, underlines indicate additions and strikethroughs indicate deletions.